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MAIL STOP AMENDMENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re:

Patent Application of

Masayuki Takashima

Group Art Unit: 1751

Conf. No.:

5605

Appln. No.

10/659,190

Examiner: Gregory E. Webb

Filed:

For:

September 10, 2003

WASHING LIQUID FOR

SEMICONDUCTOR SUBSTRATE AND

METHOD OF PRODUCING SEMICONDUCTOR DEVICE Attorney Docket No.: 683261-1US

(F-283-US/JYS)

AMENDMENT

This is in response to the Office Action dated January 3, 2006 (Paper No. 122705, hereinafter referred to as "the Office Action"), in the above-referenced application. This response is being timely filed on or before the expiration of the shortened statutory period for response which is set to expire on April 3, 2006.

Amendments to the claims begin on page 2 of this response.

Remarks begin on page 3 of this response.

Applicants respectfully request reconsideration by the Examiner in light of the following.

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